



SFP 14 2026

<p>Substitute for form 1449A/PTO</p> <p><b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b></p> <p>(use as many sheets as necessary)</p>				<p align="center"><i>SEARCHED &amp; SERIALIZED MAY 2004</i></p> <p align="center"><b>Complete If Known</b></p>	
Sheet	1	of	2	Application Number	10/815,398
				Filing Date	March 31, 2004
				First Named Inventor	Wang Yueh
				Art Unit	1752
				Examiner Name	Not yet assigned
				Attorney Docket Number	42P18694

#### **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

Examiner Signature	J. J. Juv	Date Considered	1-9-05
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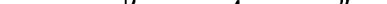
Based on PTO/SB/08A (08-03) as modified by Blakely, Salokoff, Taylor & Zalman (wtr) 08/11/2003.

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Sheet	2	of	2		

## **NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No.*	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T*
SJL		Takechi, Satoshi, et al., "Impact of 2-Methyl-2-Adamantyl Group Used for 193-nm Single Layer Resist", Journal of Photopolymer Science and Technology, Vol. 9, No. 3 (1996) Pgs. 475-488.	
		Koji Nozaki, et al. and Akiko Kotachi et al., "A Novel Polymer for A 193-nm Resist", Journal of Photopolymer Science and Technology, Vol. 9, No. 3 (1996) Pgs. 509-522.	

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